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Sul	ostitute for form 1449/PTO			Complete if Known		
				Application Number	10/584,746	
11	NFORMATION	I DI	SCLOSURE	Filing Date	June 26, 2006	
S	TATEMENT E	3Y /	APPLICANT	First Named Inventor	Ursula Ziegler	
				Art Unit	1794	
	(Use as many she	eets as	necessary)	Examiner Name	V. Chen	
Sheet	1	of	2	Attorney Docket Number	05587-00409-US	

		Document Number	D. J. E		Pages, Columns, Lines, Where	
Examiner Initials*	Cite No.	Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Relevant Passages or Relevan Figures Appear	
	AA*	US-4,493,751	01-15-1985	Hoechst Aktiengesellschaft		
	AB*	US-5,562,961	10-08-1996	Buchholz et al.		
	AC*	US-5,852,118	12-22-1998	Horrion et al.		
	AD*	US-5,977,266	11-02-1999	Reil et al.		
	AE*	US-6,044,963	04-04-2000	Lerch et al.		
	AF*	US-6,057,044	05-02-2000	Rennar et al.		
	AG*	US-6,111,029	08-29-2000	Reil et al.		
	AH*	US-6,296,797-B1	10-02-2001	Ziegler et al.		
	Al*	US-6,312,824	11-06-2001	Philippoz et al.		
	AJ*	US-20010041772	11-15-2001	Masubuchi et al.		
	AK*	US-6,384,179	05-07-2002	Tanimura et al.		
	AL*	US-6,414,081	07-02-2002	Ouhadi et al.		
	AM*	US-6,462,132	10-08-2002	Willems et al.		
	AN*	US-6,517,949	02-11-2003	Mutsuda et al.		
	AO*	US-6,777,487	08-17-2004	Niino et al.		
	AP*	US-20070154727	07-05-2007	Ziegler et al.	MATERIAL STATE OF THE STATE OF	
	AQ*	US-20070264514	11-15-2007	Prigandt et al.		
	AR*	US-20080029934	02-07-2008	Ziegler et al.		

Examiner	Cite	Foreign Patent Document	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant	
Initials*	No.1	Country Code ³ -Number ⁴ - Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Passages Or Relevant Figures Appear	1 ₀
	ВА	DE-2947490-A1	06-04-1981	Hoechst Ag		See US 4,493,751
	BB	EP-085898-A1	08-17-1983	Dow Chemical Co		
	вс	WO-94/25245	11-10-1994	Baedje K H Meteor Gummiwerke et al.		See US 5,562,961
	BD	EP-0699519-A2	03-06-1996	Shell Int Research		
	BE	DE-4434656-A1	04-04-1996	Sidler Gmbh & Co		See Abstract
	BF	DE-4439766-A1	04-04-1996	Hoechst Ag		See US 5,977,266
	BG	EP-0710703-A1	05-08-1996	Shell Int Research		
`	ВН	EP 835898	04-15-1998	Ticona		See 6,0570,044
	ВІ	EP-0837097-A1	04-22-1998	Advanced Elastomer Systems		
Examine Signatur	1	<u> </u>	d		Date Considered	A Company of the Comp

Receipt date: 09/09/2008

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PTO/SB/08b (01-08)

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IN	NFORMATIO!	N DIS	CLOSURE	Filing Date	June 26, 2006	
S	TATEMENT	BY A	PPLICANT	First Named Inventor	Ursula Ziegler	
				Art Unit	1794	
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Sheet	2	of	2	Attorney Docket Number	05587-00409-US	

			FUREIGN	PATENT DOCUMENTS		
	Foreign Patent Document		Publication	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant	
Examiner Initials*	Cite No. ¹	Country Code ⁸ -Number ⁴ - Kind Code ⁵ (if known)	Date MM-DD-YYYY	Applicant of Glob Boddinesis	Passages Or Relevant Figures Appear	T ⁶
	ВЈ	DE-19743134-A1	04-01-1999	Hoechst Ag		See US 6,296,797
	вк	WO-99/29777	06-17-1999	Advanced Elastomer Systems et al.		See US 6,414,08
	BL	WO-00/20204	04-13-2000	Ticona Gmbh et al.		See US 2008/029934
,	вм	DE-19845235	05-11-2000	Ticona Gmbh		See US 2008/029934
	BN	EP-1095962	05-02-2001	Ticona Gmbh		
	во	DE-10017486	10-11-2001	Basf Ag		

Examiner	Mission Chan!	Date	10/07/0009
	/Vivian Chen/		12/07/2000
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. * CITE NO.: Those application(s) which are marked with an single asterisk (*) next to the Cite No. are not supplied (under 37 CFR 1.96(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.